AMENDMENTS TO THE CLAIMS

Please cancel claim 2 without prejudice to its reentry at some later date.

1. (Currently Amended) A method for planarizing a surface which is formed on a substrate which comprises

providing on the surface to be planarized a liquid slurry composition comprising abrasive particles and solid lubricant particles; wherein the lubricant particles are selected from the group consisting of poly (tetrafluoroethylene), fluoroethylene-propylene copolymers, perfluoroalkoxy resins, polyvinylidene fluoride and mixtures thereof ; and wherein the amount of the solid lubricant particles is about 0.3 to about 10% by weight;

and contacting said surface with a polishing pad.

2. (Cancelled)

3. (Cancelled)

4. (Original) The method of claim 1 wherein the lubricant particles have a coefficient of friction of 0.03 to about 0.3.

5. (Original) The method of claim 1 wherein the lubricant particles have a particle size of 0.05 to about 18 microns.

6. (Original) The method of claim 1 wherein the abrasive particles comprise a member selected from the group consisting of ceria, alumina, silica, titania, zirconia, polymer particles, organic/inorganic composite particles, and combinations.

7. (Original) The method of claim 1 wherein the amount of the abrasive particles is about 0.1 to about 20 percent by weight.

8. (Previously Presented) The method of claim 1 wherein the slurry is an aqueous slurry.

9. (Previously Presented) The method of claim 1 wherein the composition further comprises a surfactant.

10-19(Cancelled)

20. (Currently Amended) A method for planarizing a surface which is formed on a substrate which comprises providing on the surface to planarized a liquid composition comprising abrasive particles and solid lubricant particles; wherein the lubricant particles are selected from the group consisting of poly (tetrafluoroethylene), fluoroethylene-propylene copolymers, perfluoroalkoxy resins, polyvinylidene fluoride and mixtures thereof; and wherein the amount of the solid lubricant particles is about 0.3 to about 10% by weight; and contacting said surface with a polishing pad.

21. (Original) The method of claim 20 wherein the surface to be polished is a thin film.

22. (Previously Presented) The method of claim 1 wherein the lubricant particles comprise poly (tetrafluoroethylene).